

IP

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Manfred FRIEDRICH, et al.
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 Filed : September 4, 2003
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 Group Art Unit : 1753
 Examiner : UNKNOWN

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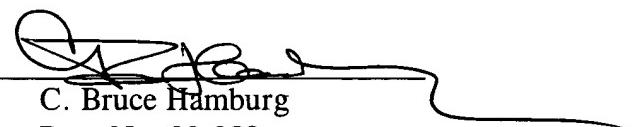
Sir:

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I hereby certify that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this statement.

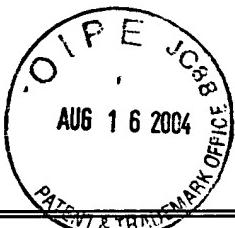
Respectfully submitted,

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INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)			Applicant: Manfred FRIEDRICH, et al.					
			Filing Date: September 4, 2003		Group: 1753			
U.S. PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
TRANSLATION KEY: * English Abstract. ^F Concise statement of relevance provided in foreign search report. ^c Concise statement of relevance provided in specification. ^s Concise statement of relevance provided in IDS. ^P Relevant portion of reference translated. ^O English abstract only - copy of reference in pct search.								
OTHER INFORMATION DISCLOSURE CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)								
		12/2/1990 "The AMS System at the Shanghai Institute of Nuclear Research" Liu Lianfan et al. Nuclear Instruments & Methods in Physics Research, Section -B: Beam Interactions with Materials and Atoms, North-Holland Publishing Company. Amsterdam, NL, Bd. B52, Nr. 3/4 Pages 298-300						
		9/1/1983 "A Versatile High Intensity Negative Ion Source" R. Middleton Nuclear Instruments and Methods, Bd. 214, Pages 139-150						
		1/2/1992 "The Hvee Tandetron Line; New Developments and Design Considerations" Mous D J W et al. Nuclear Instruments & Methods in Physics Research, Section -B: Beam Interactions with Materials and Atoms, North-Holland Publishing Company. Amsterdam, NL, Bd. B62, Nr. 3 Pages 421-424						
		2/1/1993 "Ion Sources for Accelerators in Materials Research" Alton G D Nuclear Instruments & Methods in Physics Research, Section -B: Beam Interactions with Materials and Atoms, North-Holland Publishing Company. Amsterdam, NL Bd. B73, Nr. 2. Pages 221-288						
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								